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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/722,295	11/25/2003	Young-Hun Seo	OPP 031051 US 9100		
36872	7590 11/21/2005		EXAMINER		
THE LAW OFFICES OF ANDREW D. FORTNEY, PH.D., P.C.			CHEN, JACK S J		
7257 N. MAPLE AVENUE BLDG. D, SUITE 107			ART UNIT	PAPER NUMBER	
	CA 93720		2813		
			DATE MAILED: 11/21/2005		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)					
· Office Action Summary		10/722,295	SEO, YOUNG-HUN					
		Examiner	Art Unit					
		Jack Chen	2813					
Period fo	The MAILING DATE of this communication appr r Reply	pears on the cover sheet with the	correspondence addre	SS				
A SHO WHIC - Exter after - If NO - Failur Any r	ORTENED STATUTORY PERIOD FOR REPLEHEVER IS LONGER, FROM THE MAILING DISIONS of time may be available under the provisions of 37 CFR 1.1 SIX (6) MONTHS from the mailing date of this communication. period for reply is specified above, the maximum statutory period re to reply within the set or extended period for reply will, by statute eply received by the Office later than three months after the mailing datent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATIO (36(a)). In no event, however, may a reply be ti will apply and will expire SIX (6) MONTHS from a, cause the application to become ABANDONE.	N. mely filed n the mailing date of this comm ED (35 U.S.C. § 133).					
Status								
1)	Responsive to communication(s) filed on 16 S	September 2005.						
-	•	s action is non-final.						
,	·-							
,—	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Dispositi	on of Claims							
4)⊠ Claim(s) <u>1-6 and 8-20</u> is/are pending in the application.								
•	4a) Of the above claim(s) is/are withdrawn from consideration.							
	5) Claim(s) is/are allowed.							
	5)⊠ Claim(s) <u>1-6 and 8-20</u> is/are rejected.							
•	·							
•	on Papers							
• •	•							
,	The specification is objected to by the Examine		tod to by the Evenine					
10)⊠ The drawing(s) filed on <u>25 November 2003</u> is/are: a) accepted or b)⊠ objected to by the Examiner.								
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).								
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.								
11)	ine oath or declaration is objected to by the Ex	xaminer. Note the attached Office	e Action or form PTO-	152.				
Priority u	nder 35 U.S.C. § 119							
a)[Acknowledgment is made of a claim for foreign All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureasee the attached detailed Office action for a list	ts have been received. Is have been received in Applicat rity documents have been receiv u (PCT Rule 17.2(a)).	tion No ed in this National Sta	uge				
Attachment	c(s) e of References Cited (PTO-892)	4) 🔲 Interview Summary	v (PTO-413)					
2)	e of Praftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) r No(s)/Mail Date	Paper No(s)/Mail D		2)				

DETAILED ACTION

In response to the communication filed on September 16, 2005, claims 1-6 and 8-20 are active in this application.

Drawings

The drawings are objected to under 37 CFR 1.83(a). The drawings must show every feature of the invention specified in the claims. Therefore, the ends of the anti-reflection coating are rounded must be shown or the feature(s) canceled from the claim(s). No new matter should be entered.

Corrected drawing sheets in compliance with 37 CFR 1.121(d) are required in reply to the Office action to avoid abandonment of the application. Any amended replacement drawing sheet should include all of the figures appearing on the immediate prior version of the sheet, even if only one figure is being amended. The figure or figure number of an amended drawing should not be labeled as "amended." If a drawing figure is to be canceled, the appropriate figure must be removed from the replacement sheet, and where necessary, the remaining figures must be renumbered and appropriate changes made to the brief description of the several views of the drawings for consistency. Additional replacement sheets may be necessary to show the renumbering of the remaining figures. Each drawing sheet submitted after the filing date of an application must be labeled in the top margin as either "Replacement Sheet" or "New Sheet" pursuant to 37 CFR 1.121(d). If the changes are not accepted by the examiner, the applicant will be notified and informed of any required corrective action in the next Office action. The objection to the drawings will not be held in abeyance.

Specification

The amendment filed 9/16/05 is objected to under 35 U.S.C. 132(a) because it introduces new matter into the disclosure. 35 U.S.C. 132(a) states that no amendment shall introduce new matter into the disclosure of the invention. The added material which is not supported by the original disclosure is as follows: Re claims 2, 4, 8, 10, 15 and 17 the phrase "or more" is not supported by the original specification. Re claims 3, 9 and 16, the phrase "comprises injecting at most 60sccm …and at most 200sccm of Ar gas" is not supported by the original specification.

Applicant is required to cancel the new matter in the reply to this Office Action.

Claim Rejections - 35 USC § 112

The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

Claims 2-4, 8-10 and 15-17 are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the written description requirement. The claim(s) contains subject matter which was not described in the specification in such a way as to reasonably convey to one skilled in the relevant art that the inventor(s), at the time the application was filed, had possession of the claimed invention. Re claims 2, 4, 8, 10, 15 and 17 the phrase "or more" is not supported by the original specification. Re claims 3, 9 and 16, the phrase "comprises injecting at most 60sccm ...and at most 200sccm of Ar gas" is not supported by the original specification. The remaining claims 5, 11 and 18 are rejected for depending from the above rejected claims.

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For the purposes of patentability, the claims will be interpreted as best understood.

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Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- Claims 1-4, 6, 8-10, 12-17, 19-20 are rejected under 35 U.S.C. 102(e) as being 2. anticipated by Moore et al., U.S./6,884,725 B2.

Moore et al. disclose a method of forming a trench in a semiconductor device, which comprises forming a polish stop layer 16a (fig. 10, in this case, the lower portion of the layer 16a is considered as the polish stop layer, i.e., 4/5 of layer 16a) or 16b (fig. 11, in this case, the lower portion of the layer 16b is considered as the polish stop layer, i.e., 9/10 of layer 16b) on a semiconductor substrate 12; forming an anti-reflection coating 16a (fig. 10, in this case, the upper portion of the layer 16a is considered as the anti-reflection coating, i.e., 1/5 of layer 16a) or 16b (fig. 11, in this case, the upper portion of the layer 16b is considered as the anti-reflection coating, i.e., 1/10 of layer 16b) on the polish stop layer [note: silicon nitride is inherently an antireflection coating, see U.S./6,884,733 B1, claim 2 as evidence]; selectively etching the antireflection coating to form an anti-reflection coating pattern (figs. 10 or 11); etching the polish stop layer and etching the semiconductor substrate to a predetermined depth to form a trench 20 such that ends 50 (fig. 10) or 60 (fig. 11) of the polish stop layer adjacent to the trench are

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rounded; and forming an insulation layer 28 (fig. 6) that fills the trench, see figs. 1-14 and cols. 1-8 for more detail.

Figs. 12-14 of Moore also discloses the claimed invention (i.e., at least claim 1), Moore et al. disclose a method of forming a trench in a semiconductor device, which comprises forming a polish stop layer 72 (fig. 12) on a semiconductor substrate 12; forming an anti-reflection coating 70 (fig. 12) on the polish stop layer [note: silicon oxynitride is inherently an anti-reflection coating, see U.S./6,884,733 B1, claim 2 as evidence]; selectively etching the anti-reflection coating to form an anti-reflection coating pattern (fig. 13); etching the polish stop layer and etching the semiconductor substrate to a predetermined depth to form a trench 20 such that ends of the polish stop layer adjacent to the trench are rounded (fig. 14); and forming an insulation layer 28 (fig. 6) that fills the trench, see figs. 1-14 and cols. 1-8 for more detail.

Re claims 2, 8 and 15, wherein etching is performed such that following the injection of one of argon, CF4, CHF3, plasma is created and dry etching is performed (col. 4, line 47 to col. 5, line 51).

Re claims 3, 9 and 16, wherein the etching is performed by injecting one of at most 60sccm of CHF3 gas, at most 60sccm of CF4 gas, at most 30sccm of O2 gas, at most 60sccm of HeO2 gas, and at most 200sccm of Ar gas (i.e. using 10-100 sccm argon, col. 4, lines 50-52).

Re claims 4, 10 and 17, wherein 50-500W of power is applied to generate plasma in a state where one of CHF3, CF4, O2, HeO2, and Ar is injected (i.e., using Ar at about 200 W; see col. 4, lines 47-60).

Re claim 6, wherein an area of the polish stop layer exposed through the antireflection coating pattern is etched to form the trench (figs. 10-14), and ends of the anti-reflection coating pattern are also etched such that the ends of the anti-reflection coating are rounded (figs. 10, 11 and 14).

Re claims 12 and 14 wherein the polish stop layer 16/16a/16b (figs. 1, 10-11) is deposited to about 1000 angstroms (col. 1, lines 55-58).

Re claim 13, wherein the polish stop layer is made of a material (i.e., silicon nitride, col. 1, lines 53-58) that is more slowly polished than insulation material (fig. 6, oxide 28) of the insulation layer.

Re claim 19, wherein during forming an insulation layer that fills the trench, following the formation of the insulation layer to cover the polish stop layer and inner walls of the trench, CMP is performed on the insulation layer until the polish stop layer is exposed (figs. 6-7; col. 2, lines 24-35).

Re claim 20, wherein prior to forming the insulation layer 28 (fig. 6), a liner oxidation layer 24 (see figs. 5 and 10-11) is formed on the trench and the polish stop layer, then the insulation layer is formed on the liner oxidation layer such that the trench is fill with a material forming the insulation layer (i.e. oxide, fig. 6).

Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person

having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

4. Claims 5, 11 and 18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Moore et al., U.S./6,884,725 B2.

With respect to claims 5, 11 and 18, the claimed ranges of pressure in the etching step, absent evidence of disclosure of criticality for the range giving unexpected results are considered to involve routine optimization while has been held to be within the level of ordinary skill in the art. As noted in *In re Aller 105 USPQ233*, 255 (CCPA 1955), the selection of reaction parameters such as pressure, temperature and concentration would have been obvious. See also In re Waite 77 USPQ 586 (CCPA 1948); In re Scherl 70 USPQ 204 (CCPA 1946); In re Irmscher 66 USPQ 314 (CCPA 1945); In re Norman 66 USPQ 308 (CCPA 1945); In re Swenson 56 USPQ 372 (CCPA 1942); In re Sola 25 USPQ 433 (CCPA 1935); In re Dreyfus 24 USPQ 52 (CCPA 1934).

Therefore, the subject matter as a whole would have been obvious to one having ordinary skill in the art at the time the invention was made to select any suitable pressure ranges in the method of Moore et al. in order to provide rounded corners.

Conclusion

5. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO

MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jack Chen whose telephone number is (571)272-1689. The examiner can normally be reached on Monday-Friday (9:00am-6:30pm) alternate Monday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl W. Whitehead can be reached on (571)272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Jack Chen

Primary Examiner
Art Unit 2813